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PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL. NUM 10068519	FILING DATE 02/06/2002	CLASS 101	SUBCLASS -	GAU 2854	EXAMINER Funk
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*APPLICANTS: Verschueren Eric; Van Damme Marc;

**CONTINUING DATA VERIFIED:
THIS APPLN CLAIMS BENEFIT OF 60/271,857 02/27/2001

** FOREIGN APPLICATIONS VERIFIED:
EUROPEAN PATENT OFFICE (EPO) 01000015.6 02/14/2001

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>	
Foreign priority claimed 35 USC 119 conditions met		<input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> yes <input type="checkbox"/> no	ATTORNEY DOCKET NO 215293
Verified and Acknowledged Examiners's initials			
TITLE : Cleaning method for recycling a printing substrate by laser ablation			
U.S. DEPT. OF COMM./PAT & TM-PTO-426L(Rev. 12-94)			

NOTICE OF ALLOWANCE MAILED		Assistant Examiner	CLAIMS ALLOWED	
			Total Claims	Print Claim for O.G.
ISSUE FEE		DRAWING		
Amount Due	Date Paid	Sheets Drwg.	Figs.Drwg.	Print Fig.
TERMINAL DISCLAIMER		Primary Examiner		Application Examiner
		PREPARED FOR ISSUE		
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